

# Growth Optimization and Device Integration of Narrow-Bandgap Graphene Nanoribbons

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The electronic, optical, and magnetic properties of graphene nanoribbons (GNRs) can be engineered by controlling their edge structure and width with atomic precision through bottom-up fabrication based on molecular precursors. This approach offers a unique platform for all-carbon electronic devices but requires careful optimization of the growth conditions to match structural requirements for successful device integration, with GNR length being the most critical parameter. In this work, the growth, characterization, and device integration of 5-atom wide armchair GNRs (5-AGNRs) are studied, which are expected to have an optimal bandgap as active material in switching devices. 5-AGNRs are obtained via on-surface synthesis under ultrahigh vacuum conditions from Br- and I-substituted precursors. It is shown that the use of I-substituted precursors and the optimization of the initial precursor coverage quintupled the average 5-AGNR length. This significant length increase allowed the integration of 5-AGNRs into devices and the realization of the first field-effect transistor based on narrow bandgap AGNRs that shows switching behavior at room temperature. The study highlights that the optimized growth protocols can successfully bridge between the sub-nanometer scale, where atomic precision is needed to control the electronic properties, and the scale of tens of nanometers relevant for successful device integration of GNRs.

## 1. Introduction

Graphene nanoribbons (GNRs) are strips of graphene with a distinct number of carbon atoms in their width, with exciting properties deriving from quantum confinement and related bandgap tunability.<sup>[1]</sup> The ability to modify GNRs' electronic and magnetic properties by structural design at the atomic level makes them an ideal platform for numerous device applications ranging from classical transistors to spintronics and photonics.<sup>[2–5]</sup>

Atomically precise GNRs have been successfully synthesized by surface-assisted polymerization and cyclodehydrogenation of specifically designed precursor molecules. Since the pioneering work of Cai et al. in 2010,<sup>[2]</sup> GNRs with armchair edges and different widths,<sup>[6–10]</sup> with zigzag<sup>[11]</sup> and cove<sup>[12]</sup> edges, as well as edge-extended GNRs hosting topological quantum phases<sup>[13,14]</sup> have been reported.

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For the realization of devices exploiting their exciting electronic and magnetic properties, GNRs need to be transferred from the growth substrate, usually noble metals, onto technological relevant ones such as silicon with various types of oxides.[15,16] Because of their robustness and stability under ambient conditions, AGNRs have been the most studied class of nanoribbons. AGNRs can be classified into three families according to the number of carbon atoms N across the GNR width N = 3p, 3p + 1, and 3p + 2, where p is an integer.<sup>[1]</sup> The family of 3p + 2 possesses the lowest band gap,[17,18] and is therefore most promising for high-performance electronic switching devices. However, to date, only wide-bandgap GNRs, such as 7-, 9-, 13-AGNRs, have revealed switching behavior when integrated into field-effect transistor (FET) devices. [19-21] Narrowbandgap nanoribbons available so far had limited length, increased chemical reactivity, or showed weak coupling to contacts, and consequently showed high contact resistances, all of which have limited their successful application in devices.[17,21-23]

The first member of the 3p+2 family, 5-AGNR, has first been synthesized and studied by Zhang et al, [24] followed by Kimouche et al., [6] who observed a very small electronic gap of  $\approx 100$  meV on Au(111). In a later study, Lawrence et al [18] investigated the length-dependent electronic structure of 5-AGNRs and unveiled slowly decaying topological end states localized at the ribbon termini to be responsible for the seemingly low band gap reported in the previous study. The end states in finite-length 5-AGNRs were also discussed by El Abbassi et al., [17] when investigating their quantum dot behavior in a FET-device configuration. Due to the slow decay of these in-gap states into the bulk of the GNRs, FET-devices bridged by short 5-AGNRs as the active material showed a metallic behavior at room temperature and addition energies in the range of 100–300 meV at 13 K.

The length of 5-AGNR samples produced so far has been limited to a few nanometers only, which imposes a particular

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challenge for device fabrication. To date, only graphene electrodes with sub-5 nm nanogaps created by electrical breakdown have successfully bridged short 5-AGNRs. However, the fabricated FET devices did not show switching behavior at room temperature. Growth conditions yielding longer 5-AGNRs would not only be beneficial for their integration into FET devices with traditional metal electrodes, whose minimum separation is ≈20 nm, 121 but would also allow greater overlap between GNRs and contacts to reduce contact resistance. In a previous work, 125 we have described how the use of an iodine-functionalized molecular precursor affords longer 9-AGNRs as compared to the use of the brominated compound, which was related to a reduced overlap between polymerization and cyclodehydrogenation steps resulting in limited hydrogen passivation of the growing polymers when iodine was used.

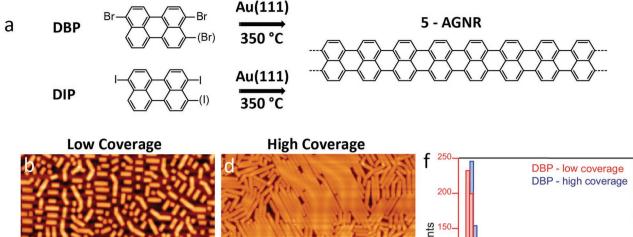
Here, we report new growth protocols to extend the maximum length of 5-AGNRs from below 10 to 45 nm and their successful integration into devices using metal electrodes with source-drain gaps of 15-20 nm. The improved growth protocols build on the use of Iodine-substituted precursors and optimized precursor coverages. Using scanning tunneling microscopy (STM) and temperature-programmed X-ray photoelectron spectroscopy (TP-XPS), we systematically investigated the impact of the precursor halogen functionalization (Br vs I) and initial coverage to unveil the growth mechanism of 5-AGNRs. Moreover, we demonstrate the robustness of 5-AGNRs by transferring them to different substrates and exploiting Raman and UV-vis spectroscopies to identify the signatures of ribbons with different lengths. Finally, 5-AGNR-FET devices with metal electrodes were fabricated and showed switching behavior at room temperature, confirming their semiconductor character.

## 2. Results and Discussion

### 2.1. STM and TP-XPS

STM and TP-XPS are two highly complementary techniques. While the former provides real-space information with subnanometer resolution, insight into the reaction kinetics with high-temperature resolution can be obtained from the latter.<sup>[25,26]</sup> Here, we applied the two techniques to clarify the influence of precursor coverage and the type of halogen substitution on the length distribution of 5-AGNRs.

To obtain 5-AGNRs samples, the precursor monomers are deposited on an Au(111) substrate, followed by an annealing step to activate dehalogenative aryl-aryl coupling and subsequent cyclodehydrogenation. Two samples with different molecular coverages (≈0.9 and ≈1.5 monolayer, ML, hereafter called low- and high-coverage, respectively) are prepared for both dibromo-perylene (DBP)<sup>[6]</sup> and diiodoperylene (DIP) precursors (**Figure 1a**) (for details on the synthesis of DIP see Methods and SI, S1–S3, Supporting Information). Representative STM images of 5-AGNRs grown from low and high coverage DBP (DIP) are shown in Figure 1b,d (Figure 1c,e), respectively. The average length of 5-AGNRs for the low-coverage cases is ≈3 nm. The length-distributions are largely dominated by dimers and trimers, as revealed by the histograms in Figure 1f,g (red



-100 80 Counts 60 40 20 0 15 20 25 30 35 40 45 DIP - low coverage DIP - high coverage -30 300 -25 250 -20 Counts 5 nm 200. -15 150. -10 100. - 5 50 25 30 35 o 5 10 15 20 Length (nm)

**Figure 1.** On-surface synthesis of 5-AGNRs from two different precursors. a) On-surface synthetic route to the formation of 5-AGNRs from the dibromoperylene (DBP) and diiodoperylene (DIP) precursors. Overview STM images of low coverage samples (0.9 ML) synthesized from b) DBP ( $V_s = 1 \text{ V}$ ,  $I_t = 60 \text{ pA}$ ) and c) DIP ( $V_s = -1 \text{ V}$ ,  $I_t = 80 \text{ pA}$ ). Overview STM images of high coverage samples synthesized from d) DBP ( $V_s = -1 \text{ V}$ ,  $I_t = 50 \text{ pA}$ ), and e) DIP ( $V_s = -1.5 \text{ V}$ ,  $I_t = 200 \text{ pA}$ ), inset:  $V_s = -0.05 \text{ V}$ ,  $I_t = 0.2 \text{ nA}$ . The blue arrow indicates 5-AGNRs on top of the first layer. f,g) Histograms showing the length distributions of 5-AGNRs synthesized from DBP and DIP starting from samples with different molecular coverage, respectively.

traces), and are comparable to those reported previously.  $^{[6,18]}$  On the other hand, the average length of 5-AGNRs in the high-coverage regime (Figure 1d,e) is significantly increased. It reveals a striking difference in average length for 5-AGNRs grown from DBP and DIP, which are  $\approx$ 5 and  $\approx$ 17 nm, respectively (blue traces in Figure 1f,g). A closer inspection of the STM images of the high coverage samples indicates the presence of a few second layer 5-AGNRs formed from the DIP (Figure 1e, see blue arrow), in contrast to the case of DBP, where no 5-AGNRs on top of the first layer are observed (Figure 1d).

Although high-resolution STM imaging provides detailed structural information on the prepared samples, [6,18] this technique is limited with respect to real-time monitoring of thermally activated reactions. To identify the intermediates and

unravel growth mechanisms as well as formation kinetics of 5-AGNRs, we carried out TP-XPS measurements, i.e., repeatedly recorded XPS spectra of the relevant core level signals during the annealing of the sample from –50 to 450 °C (heating rate of 0.2 °C s<sup>-1</sup>) (Figure 2). This investigation tracks on-surface reactions and unambiguously identifies the sequence of relevant reaction steps.<sup>[26–32]</sup> The molecular precursors were deposited onto a cold substrate (below –120 °C) to prevent their deiodination.<sup>[33]</sup> We monitored C 1s, and either Br 3d for DBP or I 4d for DIP core level signals of four samples, one with high and one with low initial precursor coverage for both, DBP and DIP. Each horizontal line of the TP-XPS maps shown in Figures 2a–d represents a single XPS spectrum of the examined core level.

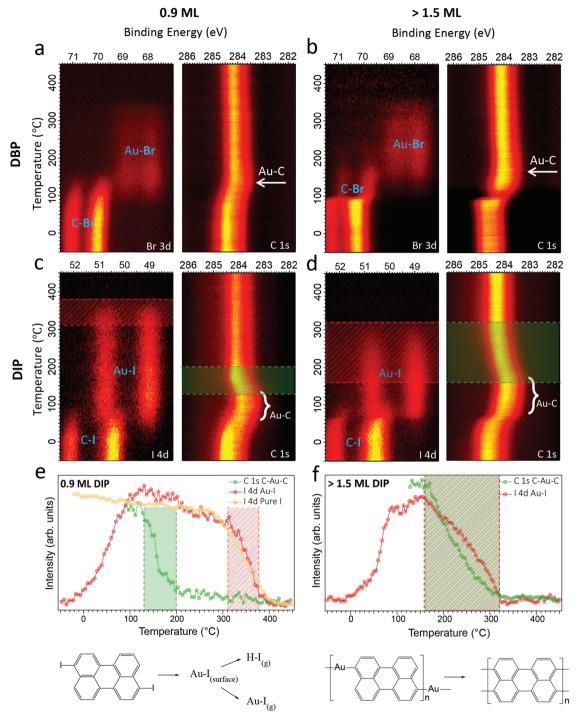


Figure 2. TP-XPS maps and kinetic curves describing the on-surface reactions. TP-XPS maps of Br 3d and C 1s core levels recorded during the heating (rate of  $0.2~^{\circ}\text{C s}^{-1}$ ) of the a) low ( $\approx$ 0.9 ML) and b) high (>1.5 ML) coverage DBP samples. c,d) TP-XPS maps of I 4d and C 1s core levels recorded during the heating (rate of  $0.2~^{\circ}\text{C s}^{-1}$ ) of the (c) low ( $\approx$ 0.9 ML) and (d) high (>1.5 ML) coverage DIP samples. The maps with high precursor coverages in (b) and (d) are normalized by the total area to highlight the energy shift. e) DIP low coverage: Intensities of the Au-I component extracted from the I 4d signal and the intensities of the OM intermediates obtained from fits of the individual spectra of the C 1s TP-XPS maps in (c). The kinetic curve of pure iodine on Au(111) is included for comparison (yellow curve, from ref [25]). f) DIP high coverage: Intensities of the Au-I signals extracted from the I 4d and the intensities of the OM intermediates obtained from fits of the individual spectra of the C 1s TP-XPS maps in (d). Green and red areas in (c), (d), (e), and (f) highlight the relevant transitions discussed in the text. The reaction schemes shown at the bottom indicate different states of the iodine and molecules during annealing.

As displayed in the Br 3d and I 4d maps in Figure 2, distinct chemical shifts of the Br 3d and I 4d doublets toward lower binding energy (BE) are discernible and attributed to the

dehalogenation of the molecular precursors and chemisorption of the halogens on the gold substrate, forming gold-halides (i.e., from C–X to Au–X, with X representing either Br or I). [26]

By extracting intensity versus temperature curves of the Au-X signals from the TP-XPS maps (shown in Figure 2e,f for DIP and in Figure S4 (Supporting Information) for DBP), we can identify the onset temperatures of deiodination (low coverage –20 °C; high coverage 0 °C) and debromination (low coverage +70 °C; high coverage +90 °C) from the decrease of the C-X and simultaneous increase of the Au-X signal. Further, the reduction of the Au-X signal at higher temperatures corresponds to halogen desorption, which is completed at 380 °C (350 °C) and 320 °C (380 °C) for low and high coverage DIP (DBP), respectively (Figure 2e,f for DIP low and high coverage, respectively and S4 for DBP).

From the TP-XPS maps of the halogen core levels, we can conclude that high initial molecular coverage slightly increases the onset temperature of dehalogenation, which we tentatively ascribe to: i) a limited molecule mobility and ii) a lower ratio of molecules per catalytically active site. Moreover, deiodination occurs at considerably lower temperatures compared to debromination due to the lower bond dissociation enthalpy for C–I with respect to C–Br.<sup>[34,35]</sup> This strongly impacts the second molecular layer, causing molecular desorption before dehalogenation for DBP, as evidenced by the significant intensity drop at 90 °C of the overall Br 3d signal in Figure 2b.

To gain more insight into the reaction mechanism, we now focus on TP-XPS maps of the C 1s core level in Figure 2. Chemical shifts toward lower BE are observed at temperatures coinciding with the previously identified dehalogenation process. From the high-resolution (HR) XPS spectrum of the low coverage DIP sample after completed dehalogenation (115 °C, Figure S5b, Supporting Information), we identify the formation of an organometallic (OM) compound, as recently observed by Berdonces-Layunta et al.[36] Upon further annealing, the C 1s spectra shift to higher BE (Figure 2c, HR-XPS in Figure S5c, Supporting Information), which implies the transformation of OM structures into 5-AGNR. The OM phase is stable over a wide temperature range when using DIP as a precursor (from 70 to 150 °C). This allowed us to acquire STM images of this OM phase (i.e., after annealing to 115 °C), which clearly revealed the presence of OM chains on the surface, spaced by chemisorbed iodine atoms (Figure S6e,f, Supporting Information). The formation of C-Au-C organometallic chains is also present but less obvious for the DBP precursor (STM image in Figure S6c, Supporting Information). There is only a small shift toward lower BE visible in the TP-XPS map, which suggests a significant overlap between the debromination and cyclodehydrogenation processes. Notably, we did not observe the C-C linked poly-perylene before forming 5-AGNR from neither XPS spectroscopy nor STM imaging for both DBP and DIP precursors, similarly to the case of the debrominative homocoupling of tetrabromonaphthalene on Au(111).[24]

Concerning the temperature evolution of the C-Au-C intermediate, we focused on the C 1s TP-XPS maps of DIP in Figure 2c,d, because of the reduced temperature difference between debromination and cyclodehydrogenation in the DBP case prevented a reasonable fit to be performed. For the low coverage case, Figure 2e, the intensities of the C-Au-C component decrease (i.e., cyclodehydrogenation takes place) above 130 °C, while for the high coverage sample this happens above 160 °C, Figure 2f. Since the transformation of the

OM chain into 5-AGNRs is accompanied by a cyclodehydrogenation process, the detached iodine atoms may combine with the released hydrogen atoms and desorb as HI, as previously shown by temperature-programmed desorption measurements in 9-AGNRs.<sup>[25]</sup> Remarkably, apart from the different onset temperatures of the cyclodehydrogenation for the DIP case at low (130 °C) and high (160 °C) coverages, the slopes of the kinetic curves are different in the way that for the low coverage sample, the weight of the organometallic phase decays more rapidly (130–200 °C) than for the high coverage sample (160 to 320 °C), as indicated by the green areas in Figures 2e,f, respectively. For the high coverage case, the temperature range over which the cyclodehydrogenation process takes place coincides with the halogen desorption.

Based on the experimental observations reported above, we provide a tentative description of the microscopic processes to explain the strongly increased 5-AGNR length obtained for the DIP at high coverage. The similar range for the iodine desorption and cyclodehydrogenation for the DIP at high coverage (red and green areas, respectively in Figure 2d,f) suggests that the two processes are closely connected. In fact, hydrogen atoms released during cyclodehydrogenation most likely combine with the detached iodine atoms present on the Au(111) surface, promoting the associative desorption as HI.<sup>[37,38]</sup> Therefore, iodine atoms can be seen as traps for atomic hydrogen, which reduces the likelihood of hydrogen-based radical passivation during GNR growth.

The efficiency of this trapping process is increased by the presumed proximity of iodine and hydrogen due to the densely packed molecular layer as well as a continuous hydrogen supply. The presence of a molecular reservoir at the second layer provides additional species to fill the empty spaces that appear due to the shrinking of the OM phase into GNRs, maintaining a high molecular density in the first layer. On the other hand, at low coverage, GNRs are formed in a narrow temperature/time range (green area in Figure 2e), releasing abundant hydrogen atoms that can easily diffuse on the surface (due to the lower molecular density) and passivate the radicals of growing ribbons. The excess hydrogen desorbs (most likely as H<sub>2</sub>) without affecting the iodine atoms that remain on the Au(111) surface. The iodine desorption kinetics from low coverage DIP samples resembles the one of pure iodine (red and yellow curves in Figure 2e, respectively), suggesting iodine desorption as AuI as proposed in previous work.<sup>[25]</sup>

#### 2.2. Raman Spectroscopy

Raman spectroscopy has been widely used to characterize carbon nanomaterials due to its ease-of-use, high throughput, and sensitivity to structural details. [39,40] GNRs present well-known Raman fingerprints that allow evaluation of their structural quality and length before and after substrate transfer as well as after device processing. [15,17,21,40,41] The Raman spectrum of GNRs is dominated by three main sets of peaks: the so-called G, CH/D, and radial breathing-like (RBLM) modes. As previously observed for graphene and carbon nanotubes, the G mode originates from in-plane vibrations of the sp² lattice [42] and is usually found  $\approx 1600 \, \mathrm{cm}^{-1}$ . The CH/D modes are



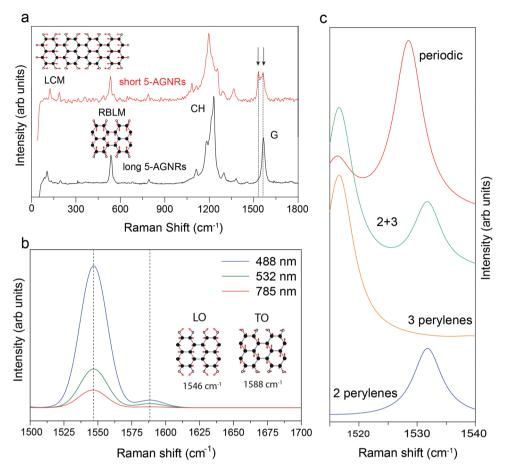


Figure 3. a) Experimental Raman spectra of short (red) and long (black) 5-AGNRs were measured in similar conditions to avoid ribbon damage: in vacuum (base pressure of  $10^{-2}$  mbar) with 785 nm laser, maps of  $10 \times 10 \ \mu m^2$  and integration time 25 s (see Figure S9, Supporting Information, for a comparison of spectra taken with 785 and 532 nm). Insets: normal mode analysis of RBLM and LCM modes. The two dashed lines highlight the appearance of two peaks in the G region for short 5-AGNRs. b) Resonant Raman simulation of the LO and TO intensities with 785, 532, and 488 nm using DFT with an LCAO basis; inset: normal mode analysis of LO and TO. c) Simulated LO frequencies as a function of 5-AGNR length using semiclassical (non-resonant) Raman and DFT with a plane-wave basis. The use of different basis sets explains why the frequencies of the LO modes do not exactly match between panels (b) and (c).

unique features due to the presence of (hydrogen-passivated) edges in GNRs that break the periodicity of the perfect sp<sup>2</sup> honeycomb lattice and are typically present in the spectral range of 1100–1400 cm<sup>-1</sup>. Lastly, the RBLM is unique to GNRs because it originates from the transverse acoustic phonon and its frequency sensitively depends on the width of armchair GNRs.<sup>[15,43]</sup> Very recently, we showed that some features of the Raman spectra are also sensitive to the length of GNRs.<sup>[40]</sup> By investigating ribbons of different lengths, we detected a lowenergy peak, the frequency of which is solely dependent on the GNR length, the so-called longitudinal compressive mode (LCM).

Here, the growth protocol-dependent average length of 5-AGNRs is used to investigate the length-dependence of the LCM fingerprint of 5-AGNRs (**Figure 3a**). While for long 5-AGNRs with an average length of 20 perylene units (obtained on the high coverage sample) the LCM was observed at  $\approx \! 100~\rm cm^{-1}$ , short 5-AGNRs, mainly perylene dimers and trimers (obtained on the low coverage sample), revealed LCM contributions at 124 and 187 cm $^{-1}$ .

Next, we focus our analysis on the high-frequency range of the Raman spectrum, in which we observe clear differences in the G peak for short and long 5-AGNRs. The G peak of GNRs is composed of two in-plane optical modes: a transverse-optical (TO) and a longitudinal-optical (LO) mode. [44] The LO and TO modes are present in all AGNR families and were previously resolved experimentally for both 7- and 9-AGNRs, with their relative intensities being strongly dependent on the excitation energy. [15]

In Figure 3a, we show the Raman profiles of long and short 5-AGNRs, both measured with a wavelength of 785 nm (1.58 eV, see also Figure S7 (Supporting Information) for UV–vis characterization from 200 to 800 nm). The experimental Raman profile for short 5-AGNRs (red) reveals two peaks in the G region, 1531 and 1563 cm<sup>-1</sup> highlighted with two black arrows, whereas for long 5-AGNRs (black) it shows a single peak at 1565 cm<sup>-1</sup>. To further understand the origin of these peaks, we used density functional theory (DFT) to investigate the vibrational modes including their length-dependent Raman features. The calculations for the periodic (infinitely long GNR) are based on a DFT

implementation of the quantum mechanical treatment of resonant Raman employing a localized atomic orbital (LCAO) basis set.<sup>[45,46]</sup> The results in Figure 3b clearly show higher intensity for the LO mode in comparison to the TO mode, and therefore the former is more likely to be observed experimentally and thus corresponds to the single G peak for 5-AGNRs at 1565 cm<sup>-1</sup> in Figure 3a.

The full quantum mechanical treatment of Raman intensity is computationally not tractable for large-size unit cells such as those needed to model finite-size AGNRs. To this end, we use the bond-polarization model to compute the semi-classical non-resonant Raman signal<sup>[47]</sup> for finite-length GNRs. In Figure 3c, we show the calculated LO Raman intensities for the periodic 5-AGNR, 5-AGNRs with 2 (dimer) and 3 (trimer) perylene units and the sum of the Raman intensities of the dimer and the trimer. It becomes clear from the simulations that the LO mode is length-dependent, especially for small lengths, and that it can be observed at different frequencies for perylene dimers (1531 cm<sup>-1</sup>) and trimers (1516 cm<sup>-1</sup>).

Although the evolution of this shift is not fully understood, the extremely short length of these structures could account for the fact that we do not see a monotonic convergence to the fully periodic situation. However, we observe a similar behavior experimentally, with two LO modes at 1563 and 1531 cm<sup>-1</sup> tentatively assigned to 5-AGNRs of length 1.7 nm (dimer) and 2.55 nm (trimer), respectively. Note that the absolute value of the G-band is shifted by  $\approx 20-30$  cm<sup>-1</sup> in the DFT calculation compared to the experiment. This is a signature of DFT's

inability of to include many-body effects, including those related to strong electron-phonon coupling.<sup>[48]</sup>

#### 2.3. Device Integration and Electrical Characterization

The tunable bandgap<sup>[3]</sup> and the atomic precision achieved through the bottom-up fabrication approach make AGNRs highly appealing for their use as the active material in room temperature switching devices.<sup>[21]</sup> Besides their stability in ambient conditions and during substrate transfer steps, GNRs must be of sufficient length to allow for efficient bridging between the electrodes.

Field-effect transistors using high dielectric constant and metallic electrodes have shown very efficient gating of AGNRs, leading to high-performance GNR devices at room temperature. [21] Here, we use the transistor structure presented in Figure 4a,b that consists of a local bottom gate geometry of ≈8 nm thick W gate capped with a ≈5.5 nm HfO₂ gate dielectric (dielectric constant = 25) and of ≈12 nm thick drain (D) and source (S) Pd electrodes (≈30–200 nm wide, ≈15–20 nm gaps). The devices are fabricated from two high coverage 5-AGNRs samples, one using uniaxially aligned 5-AGNRs achieved through growth on a Au(788) substrate with narrow (111) terraces (Figure S8a, Supporting Information), and one using randomly oriented 5-AGNRs grown on an Au(111)/mica substrate (Figure 1e). The aligned and randomly oriented GNRs are transferred for further device processing using the electrochemical

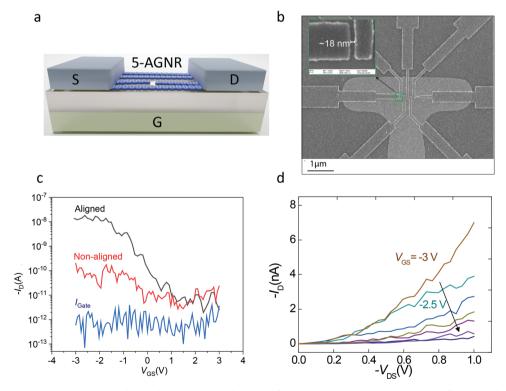


Figure 4. FETs are made with bottom-up synthesized 5-AGNRs. a) Schematic of 5-AGNR FET device. b) SEM image of 5-AGNR devices fabricated on HfO<sub>2</sub> gate dielectric and W local bottom gate with Pd electrodes. The inset is a high magnification SEM image of the source-drain gap. c)  $I_D - V_{CS}$  characteristics of an aligned and non-aligned 5-AGNR FET at  $V_{DS} = -1$  V at room temperature. d)  $I_D - V_{DS}$  characteristic of the same aligned device with varying  $V_{CS}$ .

delamination method<sup>[17,43]</sup> and the polymer-free method,<sup>[15]</sup> respectively. The well-preserved fingerprint Raman peaks (Figure S8b,c, Supporting Information) suggest the absence of significant structural modification for 5-AGNRs after substrate transfer.

Figure 4c represents typical transfer characteristics (drain current,  $I_D$ , vs gate voltage,  $V_{GS}$ ) of the aligned and non-aligned 5-AGNR FET devices at room temperature under vacuum. Both devices exhibit p-type FET behavior, alike FETs made from bottom-up synthesized 9-AGNRs and 7-AGNRs using Pd electrodes.[21,49] While the off-state currents of both devices are at the same gate leakage level, the aligned device exhibits higher on-state performance resulting in an on/off current ratio exceeding 10<sup>3</sup> which is the highest reported for bottom-up synthesized AGNRs of the low-bandgap 3p+2 family to date<sup>[17]</sup> (see Figure S10, Supporting Information for the statistical distribution of the  $I_{\rm on}$  and  $I_{\rm on}/I_{\rm off}$ ). This confirms that long 5-AGNRs are not metallic and that previously observed metallic behavior in very short GNRs (<5 nm)[17,18] is indeed due to an additional transport channel stemming from the overlap of in-gap states localized at the zigzag termini of the nanoribbons.

As shown by Lawrence et al the end states of 5-AGNRs undergo a transition from spin-split end states (8 perylene units and above) to closed-shell states because they hybridize for shorter ribbons (less than 7 perylene units). We confirm this finding by GW calculations, where we find a transition of the HOMO-LUMO gap from closed-shell to open-shell 5-AGNRs as a function of ribbon length (Figure S11, Supporting Information). The transport gap for 5-AGNRs with 20 perylene units (17 nm) is  $\approx$ 1.7 V.

The working device yield of the aligned 5-AGNR devices is also much higher than that of the non-aligned GNR devices, 82% (50 of 61) versus  $\approx$ 12% (8 of 66) respectively. Both the on-current and device yield improvements can be explained by the larger number of GNRs bridging the channel in the aligned GNR configuration. Figure 4d shows the typical output characteristic ( $I_{\rm D}$  vs source voltage  $V_{\rm DS}$ ) of the aligned GNR device. The super-linearity of the  $I_{\rm D}$ – $V_{\rm D}$  indicates the presence of a finite Schottky Barrier (SB) at the Pd-GNR interface, which is limiting the performance of the 5-AGNR devices, as also commonly reported for FETs made with other bottom-up synthesized GNRs. $^{[21,49,51]}$  The work-function engineering of the contact metal or doping of the contact area could potentially eliminate the SB effects. $^{[52]}$ 

#### 3. Conclusions

In this work, we used a combination of scanning tunneling microscopy and temperature-programmed X-ray photoelectron spectroscopy to unveil the reaction mechanisms leading to the formation of 5-AGNRs with different lengths, as identified with STM and by spectral differences in both LCM and G Raman modes. We achieved long 5-AGNRs because of the use of i) iodinated precursor molecules and ii) initial precursor coverage exceeding one monolayer, which lead to iii) the combined desorption of hydrogen released during the cyclodehydrogenation process with iodine and thus reduced hydrogen passivation of growing GNRs. Due to their increased length, the 5-AGNRs

could be successfully integrated into FET devices with a fabrication yield of 82% and  $I_{\rm on}/I_{\rm off}$  ratios exceeding 10³. Our results underline the importance of a microscopic understanding of on-surface reactions to achieve GNR layers with the desired properties to obtain switching devices that can be operated at room temperature.

## 4. Experimental Section

Synthesis of Dibromoperylene (DBP) and Diiodoperylene (DIP): DBP was synthesized according to the reported procedure, [6] affording an isomeric mixture of 3,9-dibromoperylene and 3,10-dibromoperylene. By converting Bromo groups of DBP to lodo groups, a mixture of 3,9-diiodoperylene and 3,10-diiodoperylene was obtained in 89% yield, which was used for the on-surface synthesis. The characterization data and experimental details are described in the SI.

Scanning Tunneling Microscopy: A commercial low-temperature STM (Scienta Omicron) system was used for sample preparation and in situ characterization under ultra-high vacuum conditions. The Au(111) and Au(788) single crystals (MaTeck) were cleaned by several cycles of Ar+ sputtering (1 keV) and annealing (470 °C) until clean surfaces with monoatomic terrace steps were achieved. Deposition of both the DBP and DIP precursors was performed by thermal sublimation from a 6-fold organic evaporator. STM images were recorded in constant-current mode.

The molecular coverages of the samples in Figure 1 (with coverage less than 1 ML) are determined by inspecting the STM images of the sample after depositing the precursor molecules on the Au(111) surface. Therefore, the relationship between the molecular sublimation time at a stable molecular flux (monitored by a quartz microbalance) and the molecular coverage can be well established. Then, the coverage of the samples, which is over 1 ML, can also be estimated from the molecular sublimation time. The molecular coverage of the samples in Figure 2 is extracted by examining the STM images of the samples and the areas of the XPS C 1 s intensities with respect to the Au 4f intensities.

X-Ray Photoelectron Spectroscopy: XPS measurements were performed at the X03DA beamline (PEARL endstation) at the SLS synchrotron radiation facility (Villigen, Switzerland), using linearly (and partially circularly left/right) polarized radiation with a photon energy of 425 eV. XPS spectra were obtained in normal emission geometry, using a hemispherical electron analyzer equipped with a multichannel plate (MCP) detector. HR-XPS spectra were recorded in "swept" mode with 20 eV pass energy. The TP-XPS measurement was performed during the heating of the sample (constant heating rate of 0.2 K s<sup>-1</sup>) using the "fixed" mode (snapshots of the Br 3d, I 4d, and C Is core levels) acquiring each spectrum for 5 s with 50 eV pass energy. The TP-XPS maps have a resolution of 3.5 °C in temperature and 17 s in time.

Raman Spectroscopy: Raman spectra were acquired in a homebuilt vacuum chamber with a WITec Alpha 300 R confocal Raman microscope in backscattering geometry. Measurements were performed with 785 nm laser excitation and a 300 g mm $^{-1}$  grating on 5-GNRs on Au(111), Au(788), and SiO $_2$ -based substrates. For maximum signal intensity, the laser power was maximized while avoiding optical damage  $^{[43]}$  and spectra are recorded with a Zeiss 50x LD objective, NA = 0.55, through an uncoated fused silica window of only 0.2 mm in thickness, covering a hole of just 7 mm diameter. The vacuum chamber was mounted on a piezo stage for scanning.

Device Fabrication: Preparation of Local Bottom Gate Chips: The local bottom gates were defined on a 100 nm SiO<sub>2</sub>/Si wafer by sputtering  $\approx 8$  nm W and subsequent patterning using photolithography and  $H_2O_2$  wet-etch. The  $\approx 5.5$  nm HfO<sub>2</sub> dielectric layer (Equivalent oxide thickness, EOT =  $\approx 1.8$  nm, dielectric capacitance,  $C_{\rm ox} = \approx 19.0~\mu F~cm^{-2}$ ) was grown by atomic layer deposition (ALD) at 135 °C. Alignment markers and large pads for electrical probing were patterned using photolithography followed by lift-off of  $\approx 3$  nm Cr and  $\approx 25$  nm Pt. The wafer was then diced, and individual chips were used for further device fabrication.



Patterning of Pd Electrodes: After the GNR transfer, [15,43] poly (methyl methacrylate) (molecular weight 950 kDa) was spun on the chips at 4500 rpm followed by a 10 min bake at 180 °C. Next, the drain and source electrodes (≈30–200 nm wide, ≈15–20 nm gaps) were patterned using a JEOL 6300-FS 100 kV EBL system and subsequently developed in 3:1 IPA-MIBK at 5 °C for 90 s. Finally, ≈12 nm Pd was deposited using e-beam evaporation (Kurt J. Lesker) under ≈10<sup>-8</sup> torr vacuum, and lift-off was completed in a Remover PG at 80 °C.

Electrical Characterization: The electrical characterization of the devices was performed in a Lakeshore TTPX cryogenic probe station with a vacuum level of  $<10^{-5}$  torr at room temperature, using an Agilent B1500 semiconductor parameter analyzer.

## **Supporting Information**

Supporting Information is available from the Wiley Online Library or from the author.

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## **Conflict of Interest**

The authors declare no conflict of interest.

#### **Data Availability Statement**

The data that support the findings of this study are available from the corresponding author upon reasonable request.

# **Keywords**

field-effect transistors, graphene nanoribbons, on-surface synthesis, Raman spectroscopy, scanning tunneling microscopy, temperatureprogrammed X-ray photoelectron spectroscopy

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